

Response Under 37 CFR 1.116
Expedited Procedure
Examining Group 2873

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re: U.S. Patent Application 09/760,066
Title: PROJECTION OBJECTIVE FOR MICROLITHOGRAPHY
Applicant: Schuster
Filed: January 12, 2001
Art Unit: 2873
Primary Examiner: Evelyn A. Lester
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Attorney Docket (Z) 99023 P US

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PO Box 1450
Commissioner for Patents
Alexandria, VA 22313-1450

Amendment After Final Action

Dear Examiner Lester:

This Amendment After Final Action (AAFA) responds to the Office Action
mailed September 30, 2003.

Claims as amended in the AAFA are attached hereto.

04/01/2004 AWONDAF1 00000010 09760066

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US Patent Application 09/760,066
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Schuster

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